

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
W	4,838,654	6/13/89	Hamaguchi et al.			
W	5,846,320	12/8/98	Matsuyama et al.			
W	4,951,113	8/21/90	Huang et al.			
W	4,651,408	3/24/87	MacElwee et al.			
W	5,057,898	10/15/91	Adan et al.			
W	4,988,638	1/29/91	Huang et al.			
W	5,148,301	9/15/92	Sawatsubashi et al.			
W	5,889,291	3/30/99	Koyama et al.			
W	5,818,070	10/6/98	Yamazaki et al.			
W	5,644,147	7/1/97	Yamazaki et al.			
W	5,808,595	9/15/98	Kubota et al.			
W	5,616,944	4/1/97	Mizutani et al.			
W	5,701,167	12/23/97	Yamazaki			
W	5,849,601	12/15/98	Yamazaki			
W	4,690,717	9/1987	Yamazaki			
	4,581,620	4/1986	Yamazaki			
	4,395,726	7/1983	Maeguchi			
	5,065,208	11/1991	Shah			
	4,905,073	2/1990	Chen			
	4,068,020	1/10/78	Reuschel			
	4,103,297	7/25/78	McGreivy et al.			
	4,239,346	12/16/80	Lloyd			
	4,365,013	12/21/82	Ishioka et al.			
	4,378,417	3/29/83	Maruyama et al.			
W	4,597,160	7/1/86	Ipri			

Examiner

W. J. Ny

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
NJ	4,680,580	7/14/87	Kawahara			
	4,740,829	4/26/88	Nakagiri et al.			
	4,860,069	8/22/89	Yamazaki			
	4,862,237	8/29/89	Morozumi			
	4,888,305	12/19/89	Yamazaki et al.			
	4,891,330	1/2/90	Guha et al.			
	4,897,360	1/30/90	Guckel et al.			
	4,938,565	7/3/90	Ichikawa			
	4,949,141	8/14/90	Busta			
	4,969,031	11/6/90	Kobayashi et al.			
	4,986,213	1/22/91	Yamazaki et al.			
	5,003,356	3/26/91	Wakai et al.			
	5,012,228	4/30/91	Masuda et al.			
	5,051,570	9/24/91	Tsujikawa et al.			
	5,055,899	10/8/91	Wakai et al.			
	5,056,895	10/15/91	Kahn			
	5,077,223	12/31/91	Yamazaki			
	5,084,905	1/28/92	Sasaki et al.			
	5,132,754	7/21/92	Serikawa et al.			
	5,132,821	7/21/92	Nicholas			
	5,250,818	10/5/93	Saraswat et al.			
	5,327,001	7/5/94	Wakai et al.			
	5,612,799	3/18/97	Yamazaki et al.			
	5,744,818	4/28/98	Yamazaki et al.			
	5,151,689	9/29/92	Kabuto et al.			
NJ	4,470,060	9/4/84	Yamazaki			



Examiner

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
W	4,838,654	6/13/89	Hamaguchi et al.			
	4,693,759	9/15/87	Noguchi et al.			
	4,814,842	3/21/89	Nakagawa et al.			
	4,729,009	3/1/88	Ang			
	4,760,008	7/26/88	Yamazaki et al.			
	5,289,300	2/22/94	Yamazaki et al.			
	5,372,958	12/13/94	Miyasaka et al.			
	5,247,191	9/21/93	Yamazaki et al.			
	5,250,931	10/5/93	Misawa et al.			
	4,743,567	5/10/88	Pandya et al.			
	5,315,132	5/24/94	Yamazaki			
	4,460,670	7/17/84	Ogawa et al.			
	4,500,388	2/19/85	Ohmura et al.			
	4,565,584	1/21/86	Tamura et al.			
	4,581,476	4/8/86	Yamazaki			
	4,584,025	4/22/86	Takaoka et al.			
	4,591,892	5/27/86	Yamazaki			
	4,766,477	8/23/88	Nakagawa et al.			
	4,795,679	1/3/89	Ramesh et al.			
	4,885,052	12/5/89	Fan et al.			
	4,959,700	9/25/90	Yamazaki			
	5,043,772	8/27/91	Yamazaki			
	5,236,544	8/17/93	Yamagata			
	5,270,224	12/14/93	Furumura et al.			
	5,349,204	9/20/94	Yamazaki			
W	4,772,927	9/20/88	Saito et al.			

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
JP	5,453,858	9/26/95	Yamazaki			
	4,864,376	9/5/89	Yamazaki			
	5,383,041	1/17/95	Yamazaki et al.			
	5,132,820	7/21/92	Someya et al.			
	5,082,351	1/21/92	Ferguson			
	4,818,077	4/4/89	Ohwada et al.			
	5,057,889	10/15/91	Yamada et al.			
	5,270,567	12/14/93	Mori et al.			
	4,621,276	11/4/86	Malhi			
	4,755,865	7/5/88	Wilson et al.			
	4,091,797	7/18/89	Ukai et al.			
	4,659,392	4/21/87	Vasudev			
	5,037,766	8/6/91	Wang			
	5,261,156	11/16/93	Mase et al.			
	5,281,840	1/25/94	Sarma			
	5,349,226	9/20/94	Kawaguchi et al.			
	5,402,041	3/28/95	Kishino et al.			
	5,404,175	4/4/95	Nagae et al.			
	5,418,636	5/23/95	Kawasaki			
	5,424,752	6/13/95	Yamazaki et al.			
	5,426,526	6/20/95	Yamamoto et al.			
	5,530,266	6/25/96	Yonehara et al.			
	5,539,550	7/23/96	Spitzer et al.			
	4,363,828	12/14/82	Brodsky et al.			
	5,500,538	3/19/96	Yamazaki et al.			
	5,614,732	3/25/97	Yamazaki			

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
NW	2-208943	8/20/90	Japan			Abstract	
NW	2-174170	7/5/90	Japan			Abstract	
NW	2-201967	8/10/90	Japan			Abstract	
NW	2-217826	8/30/90	Japan			Abstract	
	2-208636	8/20/98	Japan			Abstract	
	2-137822	5/28/90	Japan			Abstract	
	2-115824	4/27/90	Japan			Abstract	
	2-120330	8/21/90	Japan			Abstract	
	58-182816	10/25/83	Japan			Abstract	
	01-223719	9/6/89	Japan			Abstract	
	02-207537	8/17/90	Japan			Abstract	
	63-237570	10/4/88	Japan			Abstract	
	57-099729	6/21/82	Japan			Abstract	
	63-237571	10/4/88	Japan			Abstract	
	62-160425	7/16/87	Japan			Abstract	
	2-90531	3/30/90	Japan			Abstract	
	2-223912	9/6/90	Japan			Abstract	
	2-251992	10/9/90	Japan			Abstract	
	1-289917	11/21/89	Japan			Abstract	
	61-126595	6/14/86	Japan			Abstract	
	1-156725	6/20/89	Japan			Full	
	0321073	6/21/89	EPO			Full	
	2-51129	2/21/90	Japan			Abstract	
	1-130131	5/23/89	Japan			Abstract	
NW	0 161 555	11/21/85	European			Abstract	

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

PTO
09/499619
JCS88 U.S. PAT.
02/07/00

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
N ^W	2-103925	4/17/90	Japan			Abstract	
	2-234134	9/17/90	Japan			Full	
	55-32026	3/6/80	Japan			Full	
	64-68728	3/14/89	Japan			Abstract	
	61-141174	6/28/86	Japan			Full	
	49-77537	7/26/74	Japan				X
	62-126677	6/8/87	Japan			Abstract	
	63-100777	5/2/88	Japan			Abstract	
	1-30272	2/1/89	Japan			Abstract	
	2-188723	7/24/90	Japan			Abstract	
	58-27365	2/18/93	Japan			Full	
	53-144297	12/15/78	Japan			Abstract	
	61-004021	1/9/86	Japan			Abstract	
	01-268064	10/25/89	Japan			Abstract	
	01-289917	11/21/89	Japan			Abstract	
	2-251992	10/9/90	Japan			Full	
	58-155773	9/16/83	Japan			Full	
	55-029154	3/1/80	Japan			Full	
	58-092217	6/1/83	Japan			Full	
	60-245174	12/4/85	Japan			Full	
	60-245172	12/4/85	Japan			Full	
	59-035488	2/27/84	Japan			Full	
	59-072182	4/24/84	Japan			Full	
	60-245173	12/4/85	Japan			Full	
N ^W	3-290924	12/20/91	Japan			Abstract	

Examiner

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
PJ	59-115574	7/4/84	Japan			Full	
	55-050663	4/12/80	Japan			Full	
	55-050664	4/12/80	Japan			Full	
	58-155774	9/16/83	Japan			Full	
	58-161380	9/24/83	Japan			Full	
	59-072128	4/24/84	Japan			Full	
	59-035423	2/27/84	Japan			Full	
	55-011329	1/26/80	Japan			Full	
	01-128534	5/22/89	Japan			Abstract	
	262077	3/1/90	Japan			Abstract	
	22-23912	9/6/90	Japan			Abstract	
	58-27364	2/18/83	Japan			Abstract	
	63-96636	4/27/88	Japan			Abstract	
	5582458	6/21/80	Japan			Abstract	
	1107237	4/25/89	Japan			Abstract	
	6468724	3/14/89	Japan			Abstract	
	63-219172	9/12/88	Japan			Abstract	
	05-134272	5/28/93	Japan			Abstract	
	06-088971	3/29/94	Japan			Abstract	
	2-217826	8/30/90	Japan			Abstract	
	2-208635	8/20/98	Japan			Abstract	
	2-137822	5/28/90	Japan			Abstract	
	2-115824	4/27/90	Japan			Abstract	
	2-210330	8/21/90	Japan			Abstract	
PJ							

Examiner

Nym ✓ NY

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-2095

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 1765

 09/199619
 02/07/00
 09/199619
 02/07/00
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

pu	Akiyama et al., "An Active Matrix LCD With Integrated Driver Circuits Using a Si TFTs", Japan Display, pages 212-215.
	A.C. Adams, VLSI TECHNOLOGY, Edited by S.M. Sze, McGraw-Hill Book Company, "Chapter 6 Dielectric and Polysilicon Film Deposition", pp. 233-235.
	Scheid, et al., "Super Large Grain Polycrystalline Silicon Obtained From Pyrolysis of Si ₂ H ₆ and Annealing", Jap. J. Appl. Phys. Vol. 29, No. 11, November, 1990, pp. L 2105-07.
	Blum et al., "Low Pressure CVD Process for Micro and Polycrystalline Silicon", IBM Technical Disclosure Bulletin, Vol. 26, No. 3A, August 1983, pp. 921-22.
	Madsen et al., "In Situ Doping of silicon Films Prepared by Low Pressure Chemical Vapor Deposition Using Dililane and Phosphine", J. Electrochem. Soc., col. 137, No. 7, July 1990, pp. 2246-51.
	Wolf et al., "Silicon Processing for the VLSI Era", Volume 1: Process Technology, Lattice Press, Sunset Beach, CA (1986), pp. 175-76.
	H. Ohshima et al., "Future Trends for TFT Integrated Circuits on Glass Substrates", IEDM (IEEE 1989), pp. 157-160.
	Tsai et al., Journal of Non-Crystalline Solids, Vols. 59, 60, December 1983, Part II, pp. 731-734, Proceedings of the Xth International Conference on Amorphous and Liquid Semiconductors, Tokyo, Japan, 08/22-26/83.
	Charles MaGee and David E. Carlson, Solar Cells 2, (1980), "Investigation of the Hydrogen and Impurity Contents of Amorphous Silicon by Secondary Ion Mass Spectrometry", RCA Laboratories, Princeton, N.J., pp. 365-376.
	"The Physics of Hydrogenerated Amorphous Silicon I Structure, Preparation, and Devices", Edited by J.D. Joannopoulos and G. Lucovsky, Springer-Verlag, Berlin Heidelberg, New York, Tokyo 1984, pp. 8-9 & 38-41.
	Hatalis et al., "High Performance Thin Film Transistors in Low Temperature Crystallized LPCVD Amorphous Silicon Films", IEEE Electron Device Letters, Vol. EDL-8, No. 8, August 1987, pp. 161-64.
	Masakiyo Matsumura, "(Invited) Amorphous Silicon Transistors and Integrated Circuits", Japanese Journal of Applied Physics, Volume 22, (1983) Supplement 22-1, pp. 487-491.
	Shunsuke Kobayashi, "Color Liquid Crystal Display", December 14, 1990, pp. 162-166.
NW	M. Akiyama et al., "An Active Matrix LCD With Integrated Driver Circuits Using a Si TFTs", Japan Display, pages 212-215.

Examiner

Nym J NY

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RECEIVED

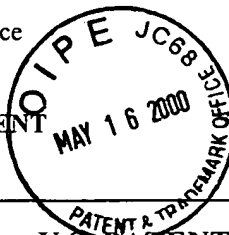
MAY 17 2000

Sheet 1 of 1

Form PTO-1449 U.S. Department of Commerce
(Rev. 8-83) Patent and Trademark Office

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

TECHNOLOGY CENTER 2815
Any Description: 0750-2095

Serial No. 09/499,619

Applicant: Shunpei YAMAZAKI

Filing Date: February 7, 2000

Group: 2815

U.S. PATENT DOCUMENTS

Examiner Initial		Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date (if approp.)
W		4,772,927	09/20/88	Saito et al.			
W		5,287,205	02/15/94	Yamazaki et al.			
W		5,568,288	10/22/96	Yamazaki et al.			
W		5,933,205	08/03/99	Yamazaki et al.			
W		5,963,278	10/05/99	Yamazaki et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
W	1	58-74080	05/04/83	Japan			Full Translation	
W	2	63-29729	02/08/88	Japan			Abstract	
W	3	4-245655	09/02/92	Japan			Abstract	
W	4	92-18644	10/22/92	Korea				X
W	5	90-17171	11/15/90	Korea				X
W	6	62-147759	07/01/87	Japan			Abstract	
W	7	3-246973	11/05/91	Japan			Abstract	
W	8	0 337 457	10/18/89	EPO			Full Translation	

OTHER DOCUMENTS (Including Author, Title, Relevant Pages, Date, Place of Publication)

Examiner

W/Jan J W/

Date Considered

5-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449
(Rev. 8-83)Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2095

Serial No: 09/499,619

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Filing Date: February 07, 2000

Group Art Unit: 2815

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
<i>NW</i>	4,697,887	10/06/1987	Okada et al.			
<i>NW</i>	4,969,025	11/06/1990	Yamamoto et al.			
<i>NW</i>	5,274,279	12/28/1993	Misawa et al.			
<i>NW</i>	5,289,030	02/22/1994	Yamazaki et al.			
<i>NW</i>	5,313,076	05/17/1994	Yamazaki et al.			
<i>NW</i>	5,341,012	08/23/1994	Misawa et al.			
<i>NW</i>	5,481,121	01/02/1996	Zhang et al.			
<i>NW</i>	5,583,347	12/10/1996	Misawa et al.			
<i>NW</i>	5,591,990	01/07/1997	Misawa et al.			
<i>NW</i>	5,616,936	04/01/1997	Misawa et al.			
<i>NW</i>	5,648,685	07/15/1997	Misawa et al.			
<i>NW</i>	5,656,826	08/12/1997	Misawa et al.			
<i>NW</i>	5,677,212	10/14/1997	Misawa et al.			
<i>NW</i>	5,712,495	01/27/1998	Suzawa			
<i>NW</i>	5,714,771	02/03/1998	Misawa et al.			
<i>NW</i>	5,744,824	04/28/1998	Kousai et al.			
<i>NW</i>	5,754,158	05/19/1998	Misawa et al.			
<i>NW</i>	5,780,872	07/14/1998	Misawa et al.			
<i>NW</i>	5,811,837	09/22/1998	Misawa et al.			
<i>NW</i>	5,851,440	12/22/1998	Tanaka et al.			
<i>NW</i>	5,904,511	05/18/1999	Misawa et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
<i>NW</i>	0 161 555	11/21/1985	EP			Full
<i>NW</i>	01-107237	04/01/1989	Japan			Abst.
<i>NW</i>	02-062077	03/01/1990	Japan			Abst.
<i>NW</i>	02-208635	08/20/1990	Japan			Abst.
<i>NW</i>	02-210330	08/21/1990	Japan			Abst.
<i>NW</i>	02-223912	09/06/1990	Japan			Abst.

Examiner *NW*

Date Considered 3-3-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

7/5/2000

Form PTO-1449
(Rev. 8-83)

Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2095

Serial No. 09/499,619

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Filing Date: February 07, 2000

Group Art Unit: 2815

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
NJ	02-251992	10/09/1990	Japan	—	—	Full	
NJ	55-082458	06/21/1980	Japan	—	—	Abst.	
NJ	64-068724	03/01/1989	Japan	—	—	Abst.	

OTHER DOCUMENT

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
NJ	Lewis, et al., "Active Matrix Liquid Crystal Display Design Using Low and High Temperature Processed Polysilicon TFTS", 1990, pp. 843-846, IEEE, CH 2865, 34.1.1

Examiner

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

7/5/2000

Form PTO-1449
(Rev. 8-83)Department of Commerce
Patent and Trademark Office

Atty Docket 0756-

Serial No. 09/499,619

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Filing Date: February 07, 2000

Group Art Unit: 2815

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
M	60-138909	07/23/1985	JP	1	1	Full Eng	



RECEIVED
FEB 22 2001
TECHNOLOGY CENTER 2800

Examiner

Mym ✓ M

Date Considered

3-7-01

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.